

# EM FOR SEM ELECTRON BEAM OEM AVAILABLE

### ISO9001:2015

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- FOR SEM, ELECTRON BEAM
- HIGH REALITY, STABILITY, LOW NOISE
- INTEGRATED OUTPUT MULTIPLE, MAX INTEGRATED SIX CHANNELS
- RS232/485 OPTIONAL
- OVER CURRENT/VOLTAGE PROTECTION
- ARC, SHORT CIRCUIT PROTECTION
- OEM CUSTOMIZATION AVAILABLE



### INTRODUCTION

Wisman's EM series is specialized in giving power to Scanning Electron Microscopes, providing acceleration, bias and filament sources in a compact package. EM series integrates the scillnator power supply, PMT power supply and collector power supply which are usually used in SEM. Wisman's unique high voltage package and encapsulation technology improve EM series' power supply in dimension, cost and performance. EM series is with high regulation, high reliability, low ripple and high stability. Accelerator supply can program voltage from 0 to -30kV at 300uA. The floating bias and filament suppliers referenced to the accelerator is provided by EM series. EM series is controlled by digital communication, which will minimize external noise to the system. EM series is with the function of accelerator current monitor, arc, short circuit, overvoltage and overcurrent protection.

### APPLICATION

SEM(Scanning Electron Microscope),Electron Beam, Metal 3D Printer, Vacuum Gun, Ion Beam Etching, Focus Ion Beam Lithography, Scientific Experiment, Industrial Applications

## SELECTION TABLE

					-							
MODEL	ACCELERATOR		FILAMENT		BIAS		SCINTILLATOR		COLLECTOR		РМТ	
	kV	uA	V	A	kV	uA	kV	uA	kV	uA	kV	uA
EM20N6	-15	200	3	3	-2	150	10	250	0.4	500	1.5	1000
EM30N9	-30	200	3	3	-2	150	10	250	0.4	500	1.5	1000

## SELECTION EXAMPLE



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**SPECIFICATION** 



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#### ACL Voltage Curren Load R Line Re Stabili BIAS Output Stabili BIAS Output Load R Line Re Ripple Tempel Stabili BIAS Output Load R Line Re Ripple Tempel Stabili Supply FIL+ Output Load R Line Re Ripple Tempel Stabili SCI Output Load R Line Re Ripple Tempel Stabili SCI Output Load R Line Re Ripple Tempel Stabili SCI Output Load R Line Re Ripple Tempel Stabili

INPUT VOLTAGE		+24Vdc, ±5%					
ACL Voltage		EM20N4 output from 20Vto -20kV; EM30N6 Output from 30V to -30kV;					
Accelerator power supply	Current	Maximum 200uA					
	Load Regulation	< $\pm$ 100ppm( from no load to full load).					
	Line Regulation	< $\pm$ 100ppm(input voltage changes 10%).					
	Ripple	≤10ppm.					
	Temperature coefficient	100ppm/°C.					
	Stability	10ppm/3min. After 1 hour's warm up.					
BIAS	Output	Output voltage ranges from 0 to -2000Vdc, Output current 0~150uA.					
B	Load Regulation	$\leq$ 0.2% (from no load to full load ).					
as p	Line Regulation	≤0.1%(input voltage changes 10%).					
power oply	Ripple	≤10ppm.					
	Temperature coefficient	25ppm/℃.					
	Stability	1% /10min,After 1 hour's warm up					
FIL +	Output	Output current 0~3A, load 1 Ω					
File	Load Regulation	$\pm$ 0.1% (from no load to full load ).					
ume	Line Regulation	$\pm$ 0.1%(input voltage changes 10%).					
int p	Ripple	≪0.1%.					
< 0ĕ	Temperature coefficient	<b>300ppm</b> /°C.					
er	Stability	100ppm/10min,After 1 hour's warm up					
SCI	Output	Output voltage ranges from 0 to 10kVdc, Output current 0~250uA.					
Pog	Load Regulation	$\leqslant$ 0.001% (from no load to full load ).					
ve	Line Regulation	$\leqslant$ 0.001%(input voltage changes 10%).					
tilla r su	Ripple	≤0.001%.					
ipp I	Temperature coefficient	<b>25ppm</b> /°C.					
<	Stability	≪0.007% /hr.≪0.01% /8hr,After 1 hour's warm up.					
COL	Output	Output voltage ranges from 0 to 400Vdc, Ouput current 0~500uA.					
Coll	Load Regulation	$\pm$ 0.001% (from no load to full load ).					
ect	Line Regulation	$\pm$ 0.001%(input voltage changes 10%).					
	Ripple	≪0.001%.					
< 00 ×	Temperature coefficient	<b>25ppm</b> /°C.					
'er	Stability	≤0.007% /hr.≤0.01% /8hr,After 1 hour's warm up.					
PMT	Output	Output voltage ranges from0 to1500Vdc, Output current from0 to1000uA.					
Microch: powe	Load Regulation	$\pm$ 0.001% (from no load to full load ).					
	Line Regulation	$\pm$ 0.001%(input Voltage changes 10%).					
anne r sui	Ripple	≪0.001%.					
e p	Temperature coefficient	<b>25ppm/℃</b> .					
ate	Stability	≪0.007% /hr.≪0.01% /8hr.After 1 hour's warm up.					
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### SPECIFICATION

Operation Temperature	0°C ~ +40°C.
Storage Temperature	-40℃ ~ +85℃.
Cooling	Convection cooling, inlet through side panel, outlet from rear panel.
Humidity	10%~90% RH, non condensing。
Dimensions	EM20N4:250mmX180mmX60mm; EM30N6:250mmX190mmX105mm
Weight	5kg₀

### +24Vdc

Jb1	Signal	JB3	Signal				
1	+24Vdc±5%	3	GND				
2	+24Vdc±5%	4	GND				
INTERLOCK							
JB2	Signal	JB2	Signal				

GND

1	INTLK Signal	2

# EMDIMENSIONS

			-
JB3	Signal	JB3	Signal
1	Spare	6	Spare
2	TXD/Transmit Data	7	Spare
3	RXD/Receive Data	8	RS485B(Optional)
4	Spare	9	RS485A(Optional)
5	GND		

RS-232/RS-485<sup>0</sup>





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